Thermal expansion behavior of ultrathin polymer films supported on silicon substrate

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The thermal expansion behavior of polystyrene (PS) thin films was investigated using x-ray reflectivity, focusing on ultrathin films below 10 nm. It was found that the glass transition temperature $T_g$ decreases with thickness as reported by many researchers while it is almost independent of thickness and constant at 354 K for films below ~10 nm. The thickness dependence of $T_g$ was well reproduced by a two-layer model consisting of a mobile surface layer with $T_g$ of 354.5 K and a bulklike layer with $T_g$ of 373 K (=bulk $T_g$), suggesting that the so-called immobile dead layer near the substrate is negligible or very thin in this system. This surface $T_g$ of 354 K was confirmed by the relaxation of surface roughness of as-deposited films at about 354 K. It was also found that the thermal expansivity decreases with thickness in the glassy state as well as in the molten state while the reduction is smaller in the molten state.

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I. INTRODUCTION

Many studies have been performed on the structure and dynamics of amorphous materials near the glass transition temperature $T_g$ using various experimental techniques to understand the nature of glass-forming materials [1–3]. About ten years ago, it was found that the $T_g$ of thin polystyrene films decreases below the bulk $T_g$, depending on thickness [4,5]. Since then, the glass transition of thin polymer films has been extensively studied [6]. One of the objectives of these studies is to elucidate the characteristic length scale responsible for the glass transition, which increases as the temperature is lowered towards $T_g$ [7,8]. In confinement systems, the correlation length is truncated by the dimension of the restrictive geometry when it reaches the system size, giving information about the characteristic length scale without knowing any physical nature of the correlations. After the first report on the $T_g$ reduction in polystyrene (PS) thin films supported on silicon by Keddie et al. [4,5], similar experimental results have been reported by many researchers [9,10]. Furthermore, Brillouin light scattering studies by Forrest et al. [11,12] elucidated that freely standing PS thin films show much larger $T_g$ reductions than supported films and there is a threshold thickness for the $T_g$ reduction, depending on molecular weight.

In some reports [13,14], the $T_g$ reduction was discussed in relation to the characteristic length scale responsible for the glass transition. However, such a $T_g$ reduction is observed only for polymer films having negligible or very weak interactions with substrates like PS and Si wafers. In fact, the glass transition temperature $T_g$ increases with decreasing film thickness for poly(methyl methacrylate) (PMMA) [4,5], which has strong interactions with Si substrate. It is now obvious that pure finite-size effects are hardly extracted from these experiments for thin polymer films supported on a solid substrate because surface and interface effects on $T_g$ are not negligible [4,5,15–17]. Hence, before discussing finite-size effects precisely, it is necessary to clarify the surface and interface effects.

Regarding the thickness dependence of thermal expansivity in glassy and molten states, there are still contradictory experimental results, depending on the experimental techniques [4,10,18,19] and thermal history of the thin films [20–22]. In previous papers [21,22], we have investigated annealing effects on the thickness of polystyrene thin films to find that the negative expansivity in the glassy state reported by Orts et al. [20] is partly caused by the unrelaxed structure due to a lack of annealing. However, it is not all of the origins for the apparent negative expansivity. In other words, the zero or very small expansivity in the glassy state is inherent in very thin films.

In this article, we have investigated the glass transition temperature $T_g$ and the thermal expansivity of PS thin films using x-ray reflectivity (XR), focusing on ultrathin films below 10 nm. The thickness of the surface mobile layer and/or the immobile dead layer near substrate is considered to be below 10 nm [4,10,18,19], and hence a detailed characterization of the ultrathin films must throw light on the characteristic nature. XR is a suitable method for this purpose rather than other methods like ellipsometry [23] because of its high thickness resolution of ~0.01 nm, giving very precise values of thermal expansivity.

II. EXPERIMENT

In this study, we used two polystyrenes with molecular weights $M_w=3.03 \times 10^5$ (Polymer Source Inc.) (PS303k) and $M_w=2.89 \times 10^6$ (Toso Inc.) (PS290k). The molecular weight distributions of both PS’s are $M_w/M_n=1.09$, where $M_w$ and $M_n$ are the weight average and the number average of the molecular weight, respectively.
Polystyrene thin films for XR measurements were prepared on cleaned Si(111) wafers. Silicon wafers prior to deposition were rinsed in ethanol and then in distilled water. Furthermore, dried wafers were cleaned in the UV ozone cleaner (NL-UV253, Nippon Laser & Electronics Lab.). Polymer solutions with various concentrations were filtered (2 μm pore size) and spun cast at 2000 rpm on cleaned silicon wafers. The thickness of the polymer film was controlled by varying the polymer concentration in solution.

XR measurements were performed using a homebuilt x-ray reflectometer which was based on a conventional powder diffractometer. Refer to Refs. [24, 25] for the data analysis in this study. The sample environment was maintained in a chamber with beryllium windows under a vacuum. The chamber was placed on the θ axis of the reflectometer. The sample temperature during the measurements was controlled within ±0.1 K with a temperature controller.

As-deposited PS thin films were introduced in the chamber and kept for 1 h under vacuum. XR measurements for as-deposited PS thin films were performed by every 5 K from 298 K to 423 K to observe the thermal relaxation behavior. The samples were kept at 423 K for 38 h in total in vacuum after this first heating ramp and then cooled down to 298 K. XR measurements were again performed by every 5 K from 298 K to 423 K to determine the thermal expansivities in the glass and the melt as well as the glass transition temperature \( T_g \) from the change of the thermal expansivities. As reported in the previous paper [22], after annealing at 423 K for more than ~2 h, the thermal expansivity and the glass transition temperature \( T_g \) are not affected by further annealing.

It took about 10 min for one XR measurement at a given temperature and the heating rate was 1 K/min, meaning that one \( T_g \) and thermal expansivity determination took about 7 h. The samples were not exposed to air after they were introduced in the chamber of the reflectometer. A θ rocking scan was performed by every 10 K during the glass measurements to check the sample alignment. Note that dewetting was observed in the films below 5 nm for PS303k and below 7 nm for PS2890k above ~400 K and hence such film data were not included in this report.

III. RESULTS AND DISCUSSION

Figure 1 shows the observed reflectivity profiles for the thinnest PS303k film with initial thickness of 6.3 nm at various temperatures. The solid curves are the results of fits, agreeing with the observed data very well. From the fits we have evaluated the thickness, the surface and interfacial roughness, and the density. Figure 2 shows a typical example of the temperature dependence of the thickness of PS303k thin films with various initial values. The thicknesses were normalized to that at 298 K for each sample. For all samples, a discontinuous change of the thermal expansivity was clearly observed, showing a definite glass transition temperature \( T_g \), which is indicated by an arrow in the figure. The expansivities in the glassy and molten states, which are shown by dashed and solid lines in the figure, respectively, are also definitely determined in the measurements. The temperature dependence of the thickness was compared with that of the density for the PS303k film with initial thickness of 6.3 nm in Fig. 3 where the data were normalized to the lowest values for comparison. The correlation between two quantities is very good, suggesting that the expansion of the film normal to the surface direction is caused by the density change.

Before going into a detailed discussion of the results, we would like to mention the annealing time effects on the glass transition temperature \( T_g \) and the thermal expansivity. In this work, we annealed the samples at 150°C for 38 h. This annealing time is longer than the terminal time for the sample with \( M_w=303 \text{ k}(\sim 2.5 \text{ min}) \), but not for \( M_w=2890 \text{ k}(\sim 90 \text{ h}) \) [26]. However, according to the discussion of Dalnoki-Veress et al. [27] an annealing time longer than the segmental relaxation (Rouse relaxation) is enough for the determination of \( T_g \). Our annealing time (38 h at 150°C) is much longer than the Rouse time (∼0.01 s at 150°C) [26].

![FIG. 1. X-ray reflectivity profiles for PS303k thin film supported on Si substrate at various temperatures after annealing at 150°C for 38 h. Initial thickness at 298 K is 6.3 nm.](image1)

![FIG. 2. Temperature dependence of film thicknesses for PS303k supported on Si substrate. The data are normalized to the value at 298 K and vertically offset for clarity. Initial thickness at 298 K is 52.9 nm (○), 17.7 nm (△), and 6.3 nm (▽).](image2)
Experimentally, we also examined the annealing time effects on the film thickness in the previous paper [22] and found two relaxation (contraction) processes during the annealing at 150°C. One is a fast structural relaxation process completed within ~2 h, and the other is an extremely slow one with relaxation time of 30–50 h, especially for thin films below ~20 nm. It was experimentally found that after the annealing at 150°C for 2 h the glass transition temperature \( T_g \) and the thermal expansivity are not affected by the further annealing if the time to measure them is shorter than the relaxation time of the slow contraction process. All the measurements in this work satisfied these annealing conditions except those on the as-deposited films. Exactly speaking, the values of expansivity reported here are not equilibrium ones because they are slightly affected by the extremely slow relaxation process [22] as well as the reptation process for \( M_w = 2890 \) k in measurements longer than the relaxation times.

Figure 4 shows the thickness dependence of the \( T_g \) for PS\(_{303k}\) and PS\(_{2890k}\) thin films. The glass transition temperature \( T_g \) of PS\(_{303k}\) thin film begins to decrease with thickness at ~40 nm as reported by many groups [28]. The \( T_g \) of PS\(_{2890k}\) also decreases with thickness while the reduction in \( T_g \) seems larger than that of PS\(_{303k}\), suggesting that the \( T_g \) of the supported thin films depends on molecular weight. It is well known that the glass transition temperature \( T_g \) in bulk does not depend on the molecular weight in the high-molecular-weight range, roughly speaking above \( M_w = 10,000 \) for PS, while it increases with molecular weight according to \( T_g = T_g^{bulk} + K/M_w \) in the low-molecular-weight range [29], where \( T_g^{bulk} \) and \( K \) are \( T_g \) at infinite \( M_w \) and a constant. Hence, it was a great surprise when the molecular weight dependence of \( T_g \) was reported in freely standing films of high-molecular-weight PS [27,30]. There have been reported some \( T_g \) data for supported thin films with various molecular weights, but the molecular weight dependence of \( T_g \) has not been explicitly discussed except for the Fukao and Miyamoto’s dielectric data [31] as far as we know. This may be because of the rather small number of points in each molecular weight data subset coupled with the substantial data scatter in the reported data [9]. The present observation suggests that the \( T_g \) of supported thin films also depends on the molecular weight, although the effect is not so large compared with freely standing films. In order to explain the molecular weight dependence of \( T_g \) for freely standing thin films, a “sliding motion” mechanism was proposed by de Gennes [32]. In this model, a chain advances along its own path. The free volume required for the sliding motion involves only the side chains and is much less than bulk cooperative motion. Sliding is blocked in the bulk because chain ends would have to invade new territory, and this requires a large free volume. Near a free surface, the situation could be different: the monomers in direct contact with the air are nearly fluid and sliding motion easily occurs near a free surface. Such sliding motion may be a possible explanation for the molecular weight dependence of \( T_g \) in supported thin films.

Another interesting feature in Fig. 4 is that the glass transition temperature \( T_g \) is almost independent of thickness and constant (~355 K) in the range below about 10 nm for both PS\(_{303k}\) and PS\(_{2890k}\). This is not the first report on \( T_g \) for thin films less than 10 nm. In the literature, in fact, we can find some \( T_g \) data below 10 nm [28]. However, the data points are too much scattered in this range, depending on experimental methods and thermal history of samples, to conclude the thickness dependence. Taking into account that XR has a high thickness resolution compared with other methods like ellipsometry [23] and the present thin films are well annealed, we believe that the glass transition temperature \( T_g \) is almost constant for ultrathin films below ~10 nm.

It is very natural to consider a mobile surface layer with lower \( T_g^{surf} \) than the bulk \( T_g^{bulk} \) on the surface of the thin film as many experiments suggested. Then, we adopted a two-layer model. Assuming that the surface and bulklike layers are \( A \) and \( A-D-A \) in thickness and have glass transition temperatures \( T_g^{surf} \) and \( T_g^{bulk}(T_g^{surf} < T_g^{bulk}) \), respectively, where
D is the total thickness of the film, the thickness dependence of the apparent \( T_g \) is given as follows:

\[
\frac{1}{T_g} = \frac{1}{D}(AT_g^\text{surf} + (D-A)T_g^\text{bulk}) \quad \text{for} \quad D \geq A
\]

\[
= T_g^\text{surf} \quad \text{for} \quad D < A.
\]

Equation (1) was fitted to the observed data and the results of the fits are shown in Fig. 4 by solid lines. The fitness is good. The parameters obtained in the fits are \( T_g^\text{bulk} = 373 \) K, \( T_g^\text{surf} = 354.5 \) K for both PS\(_{303\text{k}}\) and PS\(_{2890\text{k}}\), and \( A = 8 \) nm for PS\(_{303\text{k}}\) and \( A = 13 \) nm for PS\(_{2890\text{k}}\), respectively. The two-layer model suggests that the dead layer near the substrate is negligible or very thin in contrast to some previous works [18,19].

The surface \( T_g \) and the surface layer thickness of PS thin films have been studied using scanning microscopy by some researchers. Fischer has studied the surface of bulk PS with \( M_w = 276 \) k using thermal probe atomic force microscopy (AFM) [33] and found that the surface layer is about 14 nm thick and the surface \( T_g \) is 356 K. Scanning viscoelasticity microscopy was also used to study the surface region of the PS films in a molecular weight range of \( M_w = 4.9 \)–1450 k and it was found that the surface \( T_g \) is always lower than the bulk \( T_g \) while it depends on the molecular weight. The surface \( T_g \) of PS with \( M_n = 250 \) k is about 350 K while that of PS with \( M_n = 1450 \) k is about 360 K [34]. The thickness of the surface region was also evaluated by the same group for PS with \( M_n = 29 \) k using dynamic secondary-ion-mass spectroscopy to be about 4.8 nm [35]. These reported data are not completely in agreement, but it is safely mentioned that the surface \( T_g \) is about 10–30 K lower than the bulk \( T_g \) and the surface layer is 5–15 nm thick, being consistent with the present result except very-low-molecular-weight PS.

Fischer’s work mentioned above is suggestive. In the work, he showed that the surface roughness could be smoothed with a scanning of the thermal probe above the surface \( T_g = 356 \) K. This suggests that the rough surface of as-deposited films could be relaxed above the surface \( T_g \). Hence, we decided to observe surface relaxation behavior of as-deposited PS thin films with a relative rough surface. Figure 5 shows the temperature dependence of the surface roughness for the as-deposited PS\(_{303\text{k}}\) and PS\(_{2890\text{k}}\) films with various thicknesses. As temperature increases from room temperature, the surface roughness of the as-deposited films is almost independent of temperature and abruptly begins to decrease at around 354 K, suggesting that the onset temperature of surface relaxation is 354 K and almost independent of molecular weight. This observation strongly supports the conjecture that the surface \( T_g \) of the PS films is about 354 K.

In the next step, we will consider the thickness dependence of thermal expansivity of PS thin films. Thermal expansivities below and above the glass transition temperature \( T_g \) were evaluated from the slopes of the straight lines in Fig. 2 and plotted as a function of the thickness in Figs. 6(a) and 6(b), respectively, for both PS\(_{303\text{k}}\) and PS\(_{2890\text{k}}\). First, we will focus on the thickness dependence of the thermal expansivity in the glassy state. As seen in Fig. 6(a), the expansivity in the thickness range above \( \sim 65 \) nm is \( \sim 1.3 \times 10^{-4} \) for both PS\(_{303\text{k}}\) and PS\(_{2890\text{k}}\), which is close to the expected value.
THERMAL EXPANSION BEHAVIOR OF ULTRATHIN...
[28] See Fig. 1 in Ref. [10].